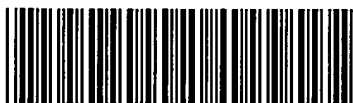


**Search Notes**

Application/Control No.

10/553,684

Examiner

Hai H. Huynh

Applicant(s)/Patent under  
Reexamination

YATABE, FUMIO

Art Unit

3747

**SEARCHED**

Class	Subclass	Date	Examiner
123	399	8/10/2006	HHH
123	299	8/10/2006	HHH
123	300	8/10/2006	HHH
123	305	8/10/2006	HHH
123	494	8/10/2006	HHH
73	118.2	8/10/2006	HHH

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East	8/10/2006	HHH